

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Craig L. Stevens, et al.

Serial No. Unknown

Examiner: Unknown

Filed: Herewith

Art Unit: Unknown

For: ARCHITECTURE FOR HIGH
THROUGHPUT SEMICONDUCTOR
PROCESSING APPLICATIONSJC997 U.S. PTO
09/872796
06/01/01Commissioner for Patents
Washington, D.C. 20231INFORMATION DISCLOSURE STATEMENT

Sir:

The information listed below may be material to the examination of the above-identified application. Copies of the cited reference(s) and a completed PTO-1449 form are submitted herewith. The Examiner is requested to make this information of official record in the application.

Applicants would appreciate the Examiner's initialing and returning the Form PTO-1449, indicating that the reference(s) have been considered and made of record herein.

The Information Disclosure Statement under 37 CFR §1.97 is not to be construed as a representation that: (i) a search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

If for any reason an insufficient fee has been paid, the Commissioner is hereby authorized to charge any deficiency in payment of required fees associated with this communication to Deposit Account **05-0150**.

Dated: June 1, 2001

Respectfully submitted,

Squire, Sanders & Dempsey L.L.P.
600 Hansen Way
Palo Alto, CA 94304-1043
Telephone: 650.856.6500
Facsimile: 650.843.8777

Patrick D. Benedicto
By: Patrick D. Benedicto
Registration No. 40,909
Attorney for Applicant(s)